## TS-P Series Laser Triangulation Displacement Sensor\*<sup>7</sup>



## **TS-PD08 Product Parameter**



Reference Distance*1	8 mm
Measurement Range	±0.8 mm
Spot Diameter	Φ20 μm
Repeatability*2	0.03 µm
Repeatability*3	0.01 µm
Linear Error*4	<±0.5 μm
Outer Diameter*Length	82*115*38.5 mm
Weight	213 g
Sample Frequency	Max. 160 kHz
Light Source*5	655 nm,Max.4.9 mW
<b>Temperature Characteristics</b>	0.01% of F.S./°C
Industrial Interface*6	Ethernet,RS-485 serial port,analog signal output(Max.±10 V, 4~20 mA)
Measurement & Control Software	Comes with TSLaserStudio measurement & control software,C++&C# SDK
Operating Mode	Operates independently without a controller. The head can be configured as a master or slave, the master controls the slave to achieve functions such as synchronous thickness measurement, alternating exposure for interference resistance
Supply Voltage	DC 9~36 V,maximum allowable ±10% fluctuation
Power Consumption	Approx.2.5 W
IP Grade	IP67 (IEC60529)
Operating Temperature	0 to +50°C

<sup>\*1</sup> Calculation based on the center position of the measurement range;

<sup>\*2</sup> Measurement of standard white ceramic sample, 50kHz without averaging, taking the root mean square deviation (1 σ) of 65536 sets of measurement data; U series probes, 8kHz without averaging, taking the root mean square deviation (1 σ) of 65536 sets of measurement data;

<sup>\*3</sup> Measurement of standard white ceramic sample, 50kHz with 1024 averaging times, taking the root mean square deviation (1  $\sigma$ ) of 65536 sets of measurement data; U series probes, 8kHz with 1024 averaging times, taking the root mean square deviation (1  $\sigma$ ) of 65536 sets of measurement data;

<sup>\*4</sup> Calibration and verification using nanometer-level high-precision laser interferometer;

<sup>\*5</sup> Laser power can be customized according to different application requirements, some models provide 405nm blue light version;

<sup>\*6</sup> The probe can independently provide voltage, current, and RS-485 output, Optional analog voltage/current output module.

<sup>\*7</sup> For the sub-series, PD indicates a split-type structure, and PM indicates a mirror-reflection calibration type. The different suffixes are distinguished as follows: W for wide spot, U for ultra-wide spot, B for blue laser, and H for high-power laser.

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## **TS-PD08 Product Dimension Drawing**

